## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Vyvoda, et al.

Application No.:

09/776009

Group Art Unit: 2814

Filed: 02/02/2001

Examiner: Anh D. Mai

Title: Wafer Surface that Facilitates

Particle Removal

Attomey Docket No.: MA-027

Assistant Commissioner for Patents

July 3, 2003

Washington, D.C. 20231

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## OFFICE ACTION RESPONSE AFTER FINAL

Please enter the following remarks in response to the Office Action of May 7, 2003, and is filed within two months of mailing of the Office Action. In this response no claims are amended, cancelled or withdrawn, and no new claims are proposed. As there are no changes to the claims, no listing of pending claims is included.

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App. No. 09/776009

1

Matrix Semiconductor, Inc. 3230 Scott Boulevard Santa Clara, California 95054 Telephone 408.969.4848 Facsimile 408,969,4849

Date: \_\_July 3, 2003

Time:

(Santa Clara, California)

TO:

Commissioner for Patents

Attn: Anh D. Mai

Patent Examining Corps

Facsimile Center

Washington, D.C. 20231

FROM:

Pamela J. Squyres

OUR REF: <u>MA-027</u>

TELEPHONE: 408-869-2921

FAX NUMBER 703-308-7722

\* Please deliver to Examiner Anh D. Mai in Art Unit 2814. \*

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Re:

Patent Application of: Michael A. Vyvoda et al.

Examiner:

Anh D. Moi

Serial No.: 09/776009

Group Art Unit:

2814

Filed:

February 2, 2001

Docket No.:

MA-027

Title:

Wafer Surface that Facilitates Particle Removal

Name: Pamela J. Squyres

Reg. No.: 52,246

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